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CONFIRMATION NO. 4799

Bib Data Sheet

SERIAL NUMBER 10/689,617	FILING OR 371(c) DATE 10/22/2003 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 12732-170001
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APPLICANTS

Satoru Okamoto, Isehara, JAPAN;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2002-310257 10/24/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/17/2004

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 95	INDEPENDENT CLAIMS 13
35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> <small>Examiner's Signature</small> <i>[Initials]</i> <small>Initials</small>				

ADDRESS

26171

TITLE

Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device

FILING FEE RECEIVED 2980	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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